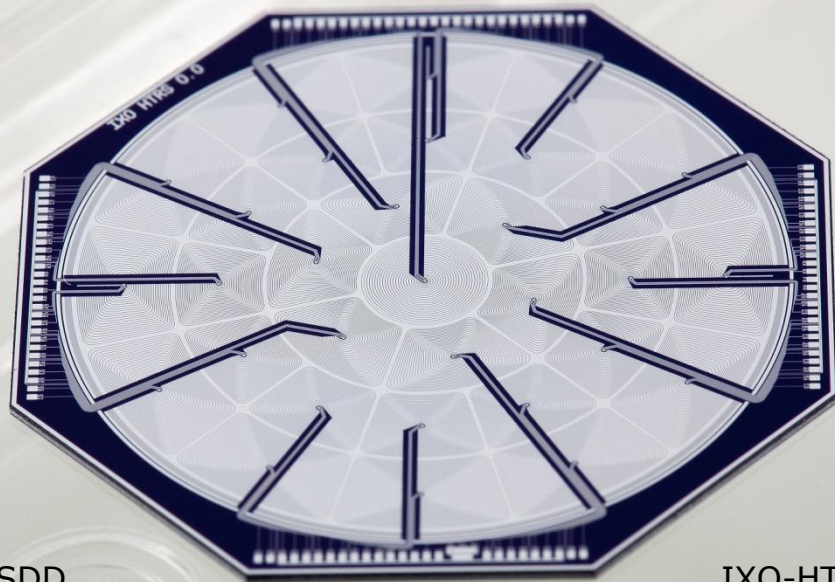
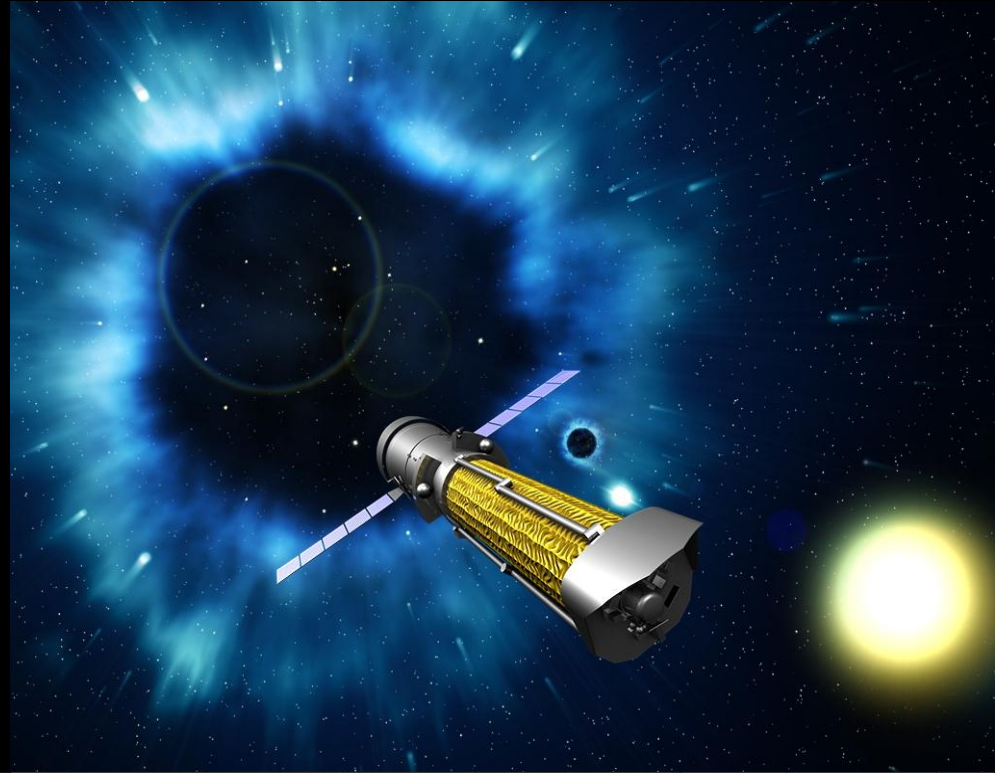


Semiconductor detectors for IXO and more

Peter Lechner
PNSensor & MPI HLL

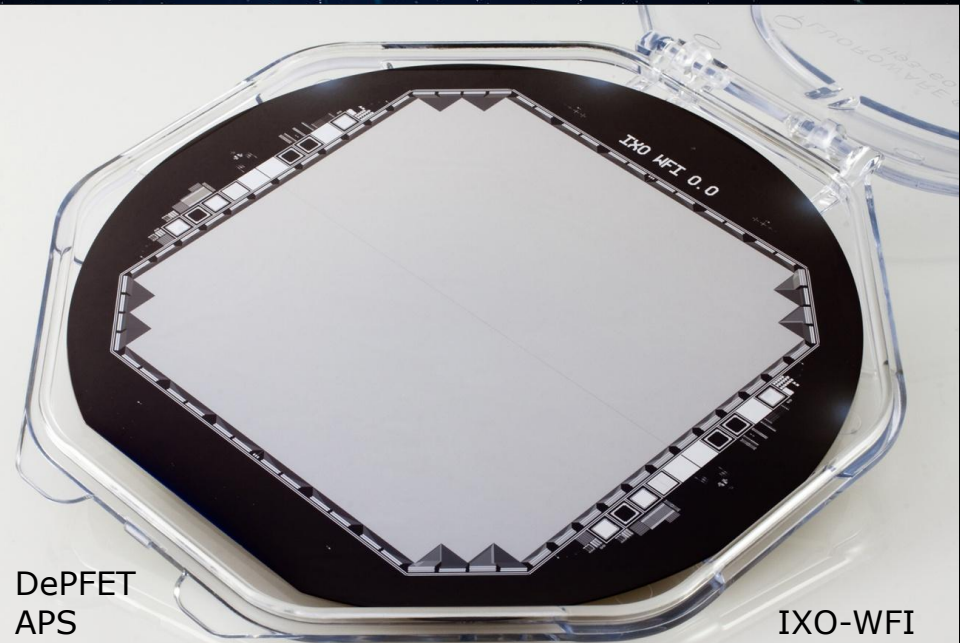
Experimental High Energy Astrophysics
Challenges for the new Decade

Tübingen, 16.07.10



SDD

IXO-HTRS



DePFET
APS

IXO-WFI

■ diode

▷ electronic noise

$$ENC = \sqrt{\alpha \frac{2kT}{g_m} C_{tot}^2 A_1 \frac{1}{\tau} + 2\pi a_f C_{tot}^2 A_2 + q I_L A_3 \tau}$$

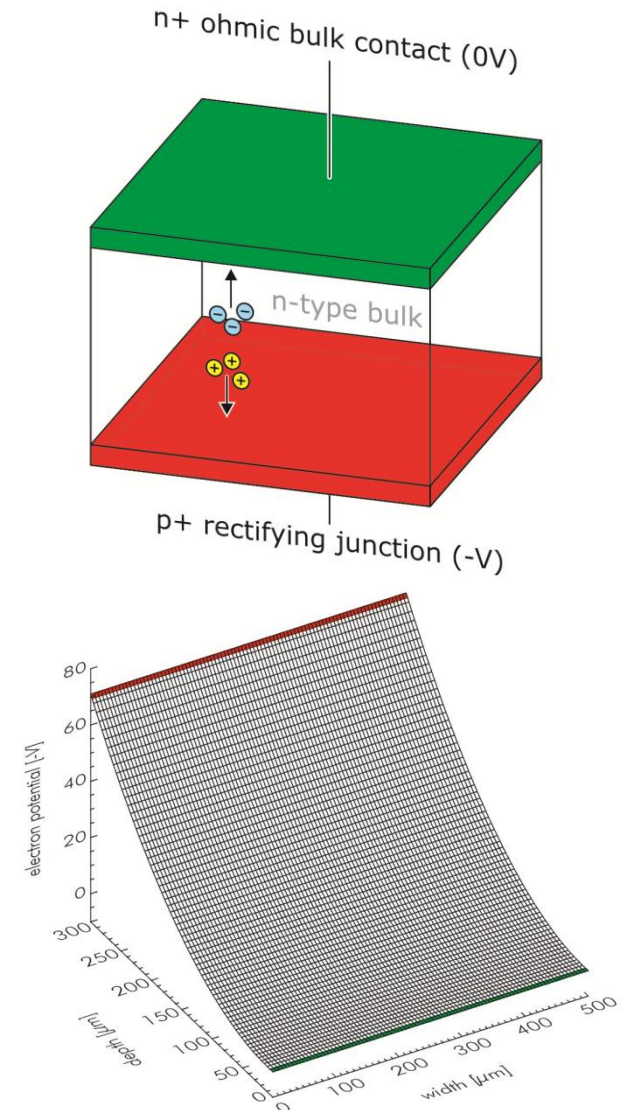
▷ optimum shaping time

$$\tau_{opt} = \sqrt{\frac{2A_3}{A_1} \frac{kT}{q} \frac{C_{tot}^2}{I_L} \frac{2}{3g_m}}$$

↳ for

- **good resolution**
- **high count rate capability**

the capacitance must be minimised!!



■ sideward depletion structure

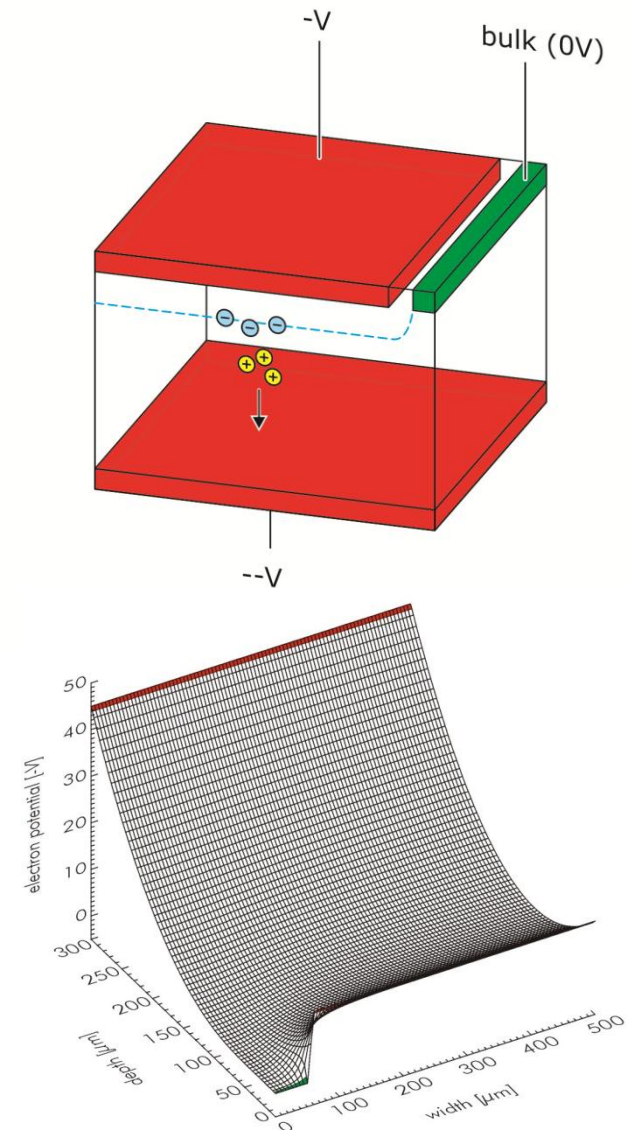
Emilio Gatti & Pavel Rehak, 1983

- ▷ symmetric bias
- ▷ volume is fully depleted by reverse biased diodes on both surfaces
- ▷ minimum capacitance of bulk contact, independent of overall area
- ▷ potential minimum for majority carriers (electrons @ n-Si) in the center plane

- ▷ asymmetric bias
- ▷ vertical shift of the potential minimum

?? signal extraction ??

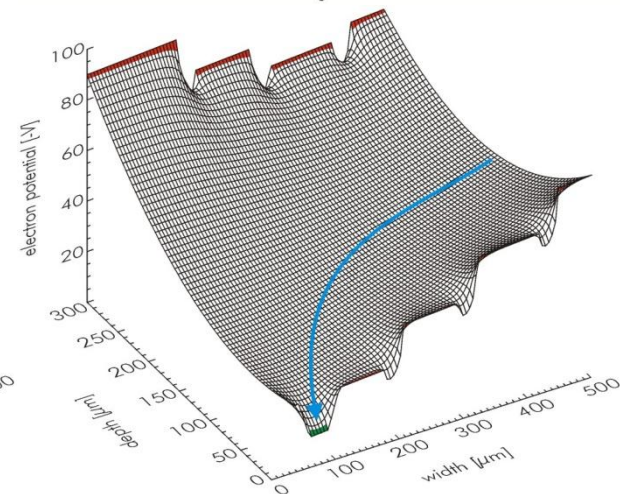
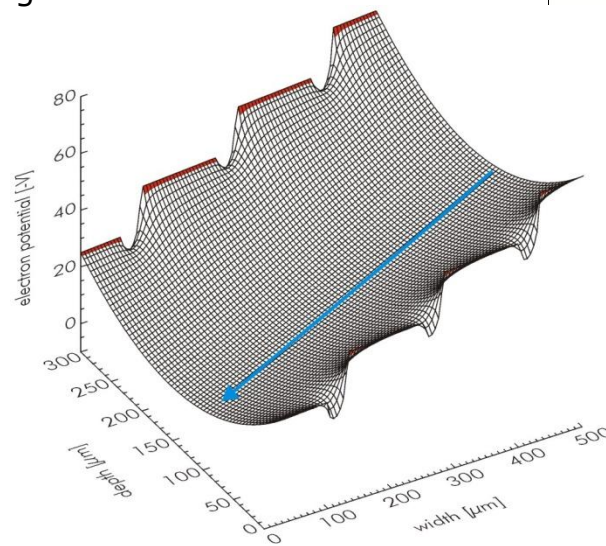
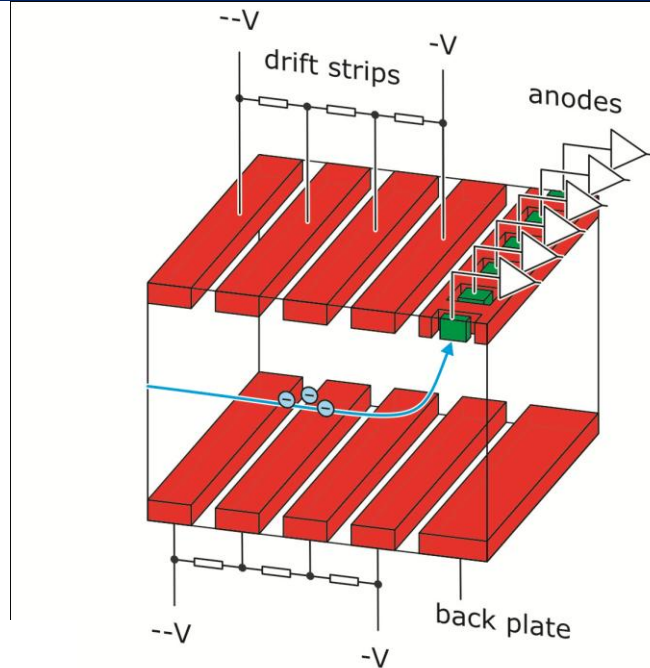
↳ **advanced detector concepts**



■ linear silicon drift detector (SDD)

Emilio Gatti & Pavel Rehak, 1984

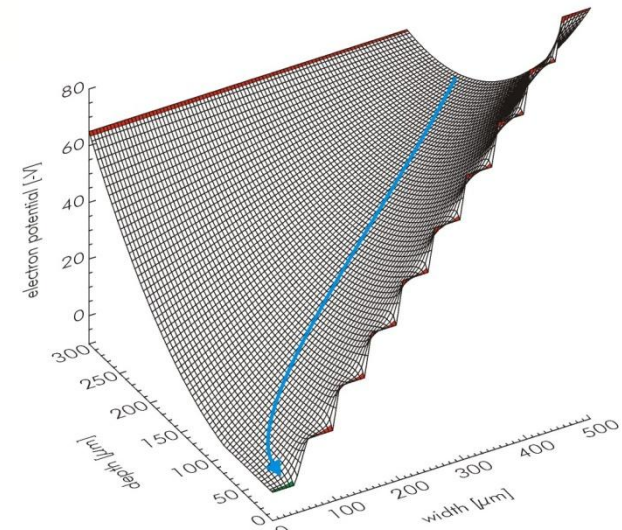
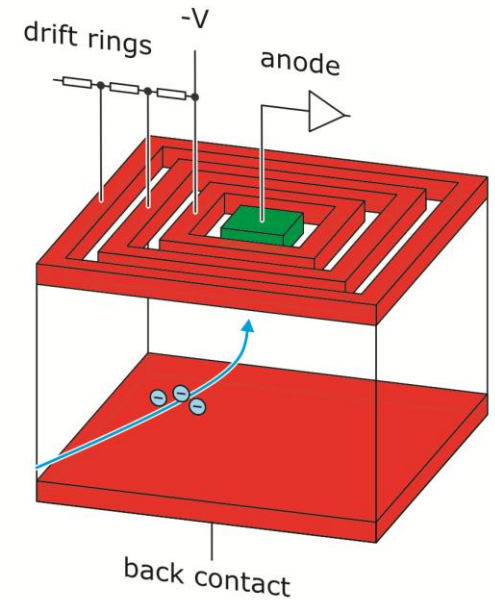
- ▷ segmentation and bias of diodes
 - ↳ drift field \parallel surface
- ▷ 2dim position resolution by
 - drift time measurement (trigger!)
 - segmentation of the anode
- ▷ application: particle tracking



■ spectroscopy SDD

Josef Kemmer & Gerhard Lutz, 1987

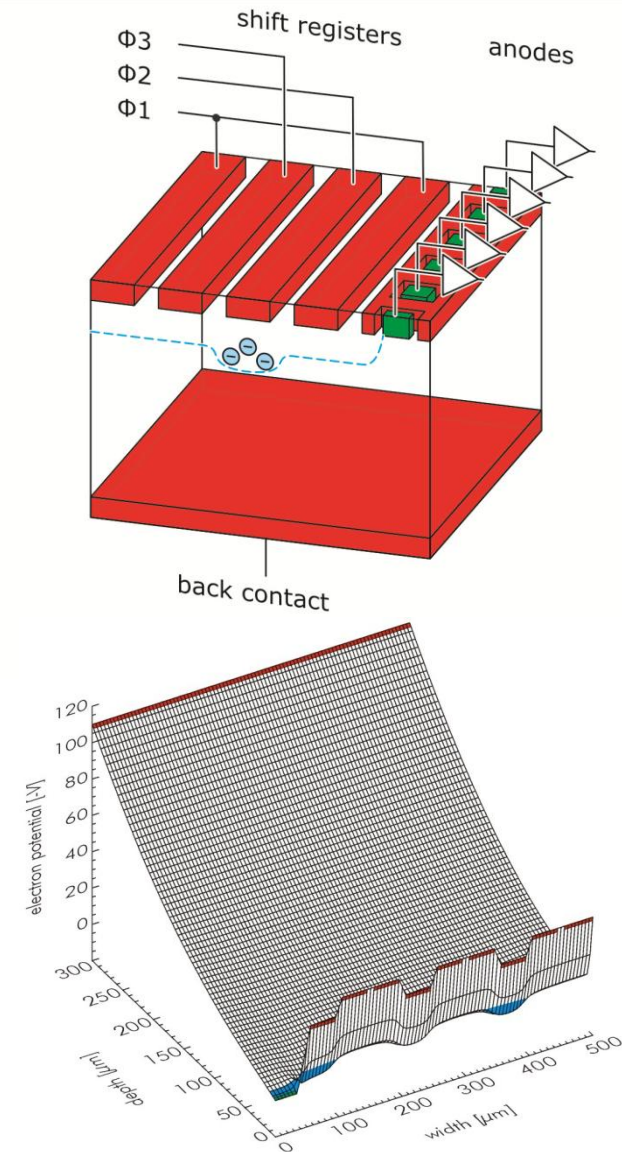
- ▷ one-sided field strip system
 - ↳ optimized for photon spectroscopy
 - ↳ irradiation through homogeneous thin entrance window
- ▷ integrated 1st FET
 - ↳ low noise
 - ↳ robust against pickup & microphonic noise



pnCCD

Lothar Strüder et al., 1987

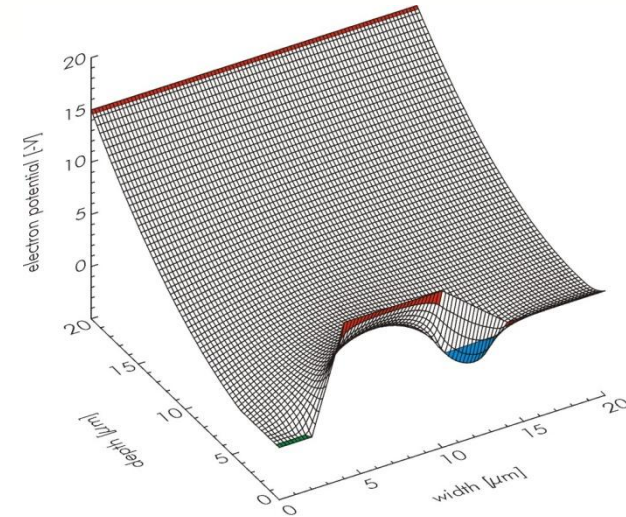
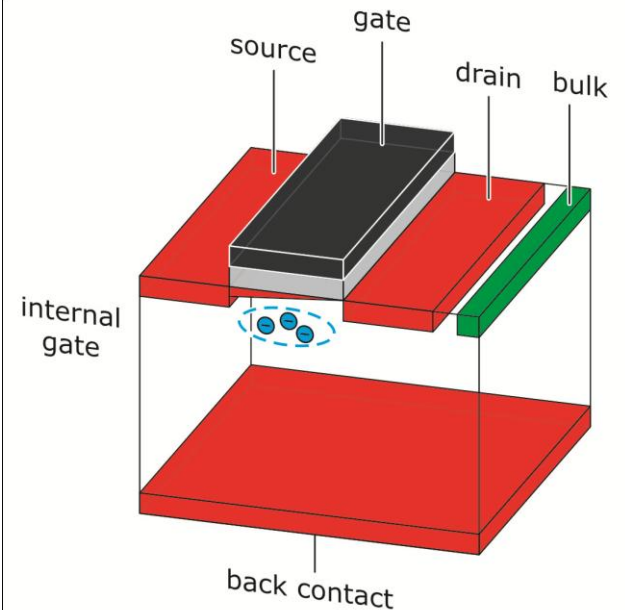
- ▷ definition of potential pockets by differently reverse-biased diodes
- ▷ charge transport by periodic clocking of shift registers
- ▷ column-parallel readout
 - ↳ high frame rate
- ▷ integrated 1st FET (1 / column)
 - ↳ low noise
- ▷ backside illuminated, fully depleted
 - ↳ quantum efficiency



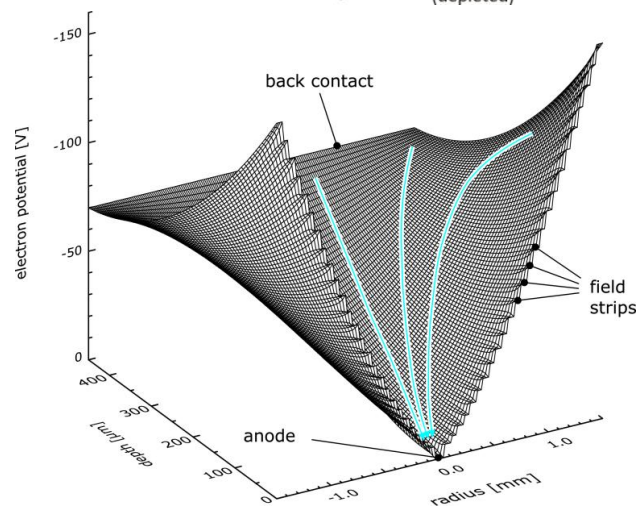
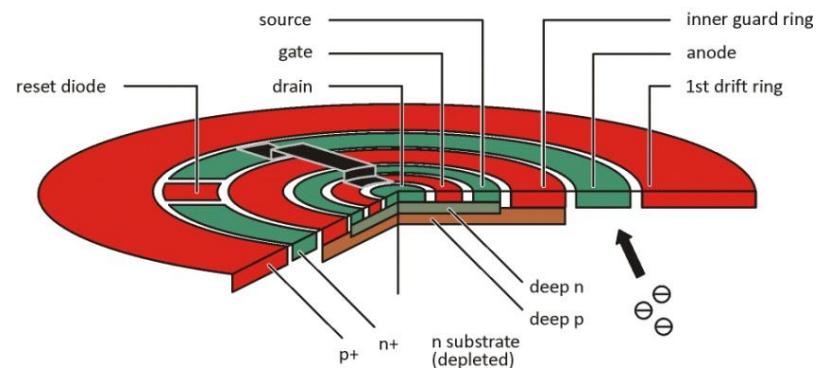
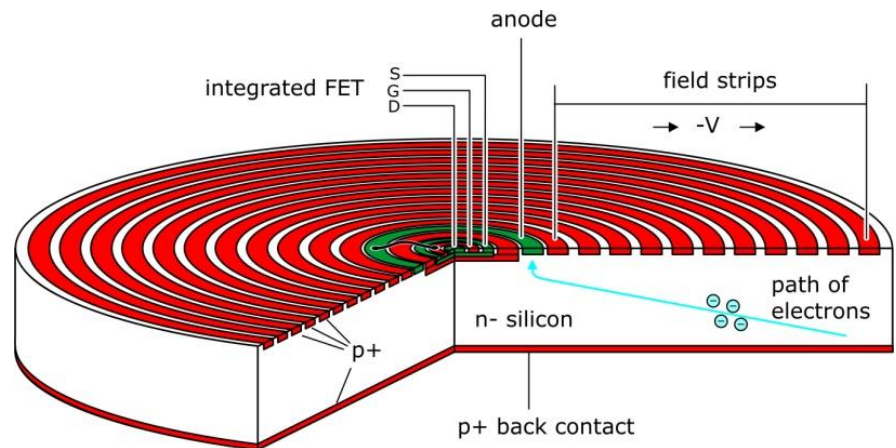
DePFET

Josef Kemmer & Gerhard Lutz, 1987

- ▷ p-MOSFET on depleted n-substrate
- ▷ combined detector & amplifier function
- ▷ localized potential minimum under gate = 'internal gate'
 - ↳ modulation of FET current (300 pA/el.)
- ▷ low capacitance (20 fF) and noise
 - ↳ excellent spectroscopic performance
- ▷ charge storage capability
 - ↳ readout on demand
- ▷ non-destructive readout
 - ↳ potential of repetitive readout
- ▷ complete clearing of signal charge
 - ↳ no reset noise
- ▷ backside illuminated, fully depleted
 - ↳ quantum efficiency

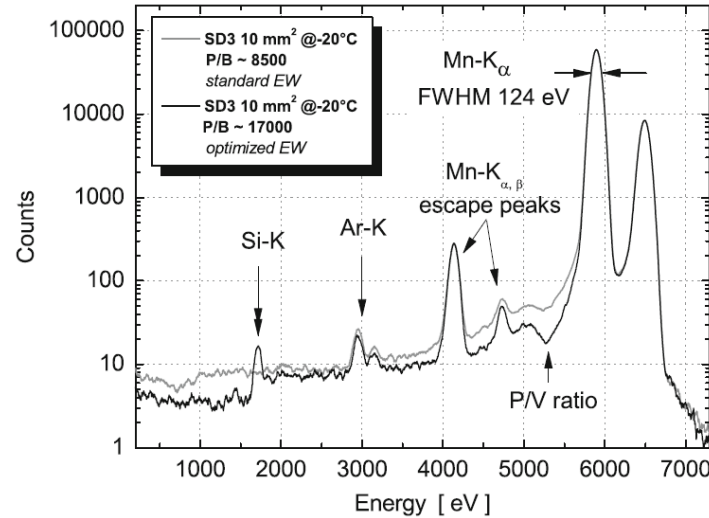


- large sensitive area
 - ▷ low electronics noise
 - ▷ high count rate
 - ▷ insensitive to pickup & microphony
- low leakage current level
 - ▷ room temperature / moderate cooling
- homogeneous entrance window
 - ▷ backside illumination
- flexible in shape and size
 - ▷ 5 ... 100 mm²
- multichannel arrays



■ spectroscopy

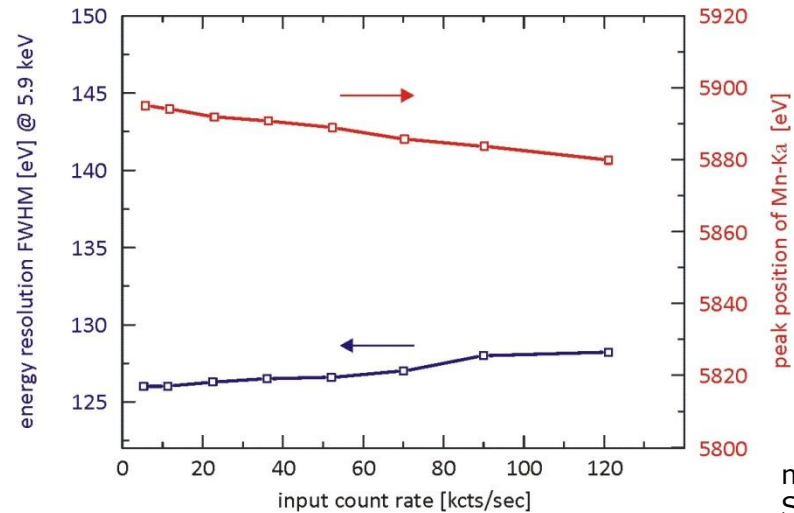
- ▷ SDD 10 mm², -20 °C
- ▷ energy resolution
 - 124 eV FWHM @ 5.9 keV
- ▷ peak / background ratio
 - 8.500 ... 17.000 @ 6 keV / 1 keV



measured
SDD 10 mm²

■ count rate capability

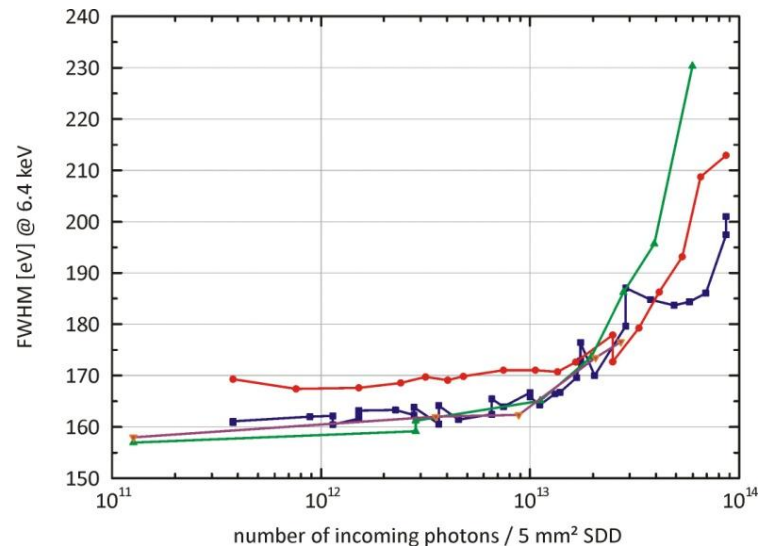
- ▷ charge sensitive amplifier configuration
- ▷ pulsed reset
- ▷ stable performance up to > 100 kcps
 - resolution ~ % level
 - peak position ~ ‰ level



measured
SDD 5 mm²

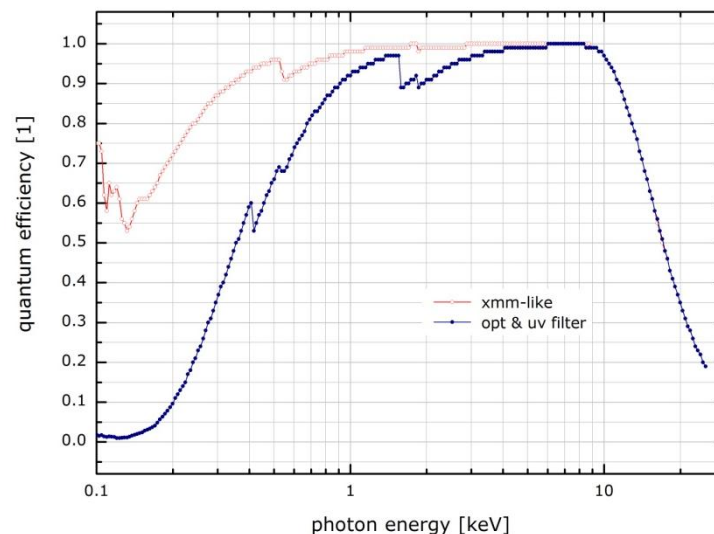
■ long term stability

- ▷ no effect up to 10^{13} photons
(18 keV, 300 μm thick device)



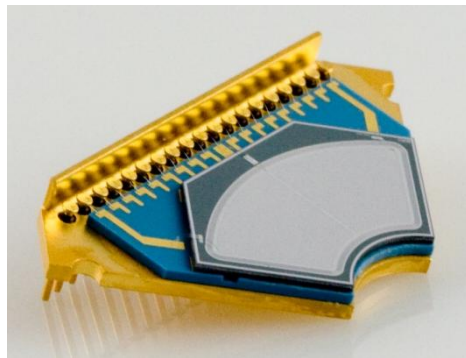
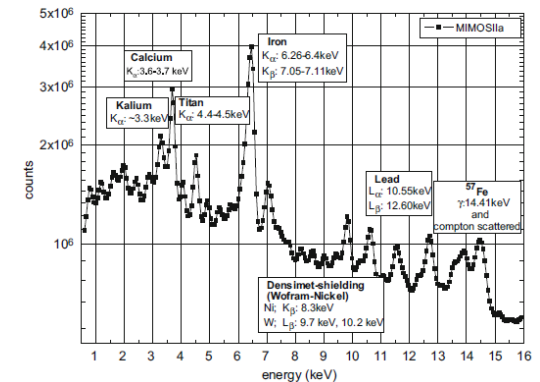
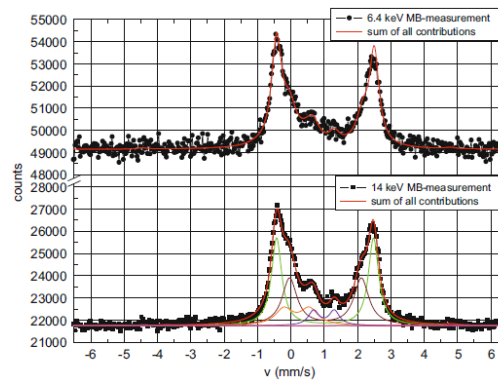
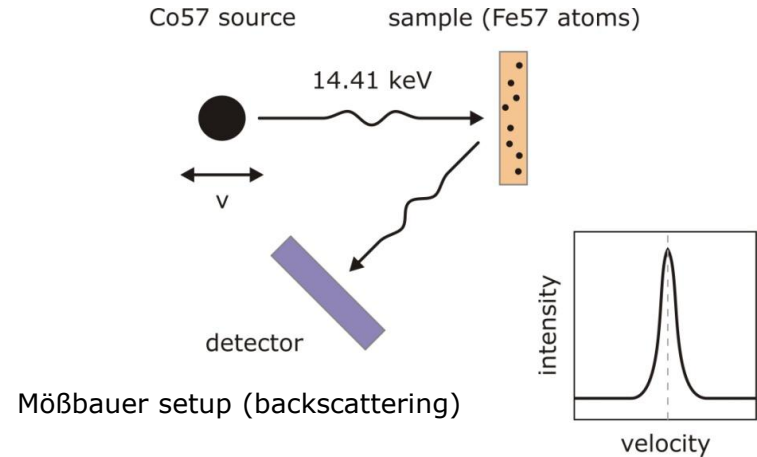
■ quantum efficiency

- ▷ low energy limit
radiation entrance window
(Si dead layer, light blocking filters)
- ▷ high energy limit
Si thickness, 450 μm

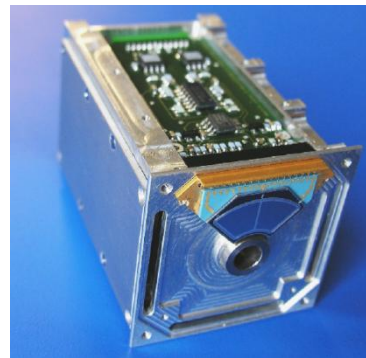


Möbbaauer spectroscopy

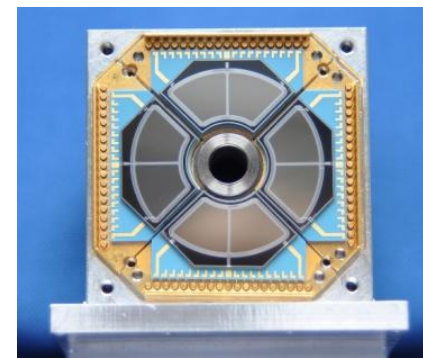
- ▷ resonant recoil-free emission/absorption of γ -rays by nuclei of solid-bound atoms
- ▷ nuclear levels of emitter/sample shifted and hyperfine split by chemical environment
- ▷ probing of levels by red/blue-shift
- ▷ resolution $E/\Delta E \sim 10^{12}$
- ▷ MIMOS-IIa (Uni Mainz)
- ▷ 8 x 45 mm² SDDs
- ▷ simultaneous XRF
- ▷ ExoMars mission
- ▷ demonstration at Hawaiian volcano crater



SDD module, 2 x 45 mm²



MIMOS-IIa assembly

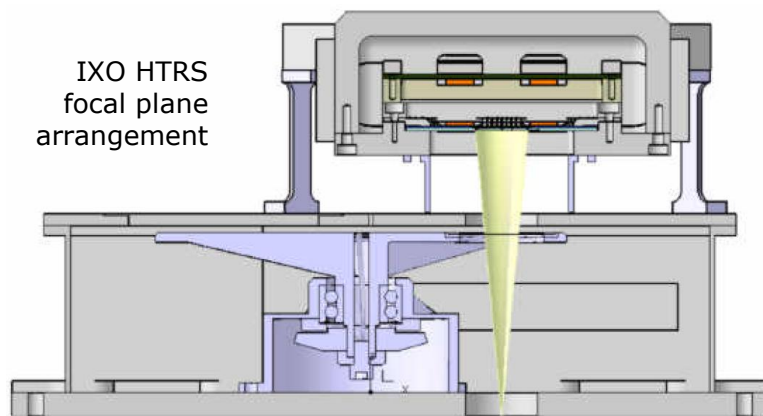


MIMOS-IIa sensor head

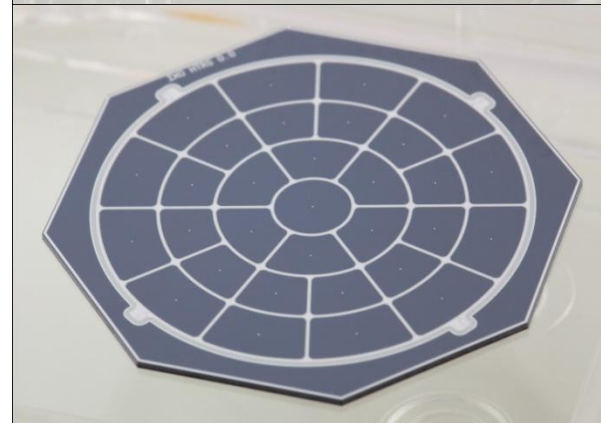
G. Klingelhöfer
Uni Mainz

IXO High Time Resolution Spectrometer

- ▷ X-ray timing & spectroscopy
 - time resolution 10 μ sec
 - 150 eV FWHM @ 6 keV
 - < 2 % pileup & deadtime @ 1 Crab
- ▷ multi-channel SDD, 31 x 14.6 mm²
- ▷ out-of-focus distance 11.3 cm
- ▷ r/o electronics development
 - 8-channel analog ASIC ($\tau \sim 600$ nsec)
 - digital chain ($\tau \sim 200$ nsec)
- ▷ 7-cell prototype SDD available end10



mechanical sample:
readout side



radiation entrance
window side



'spider web'
collimator for split
event suppression

200 μ m spokes
10 % coverage

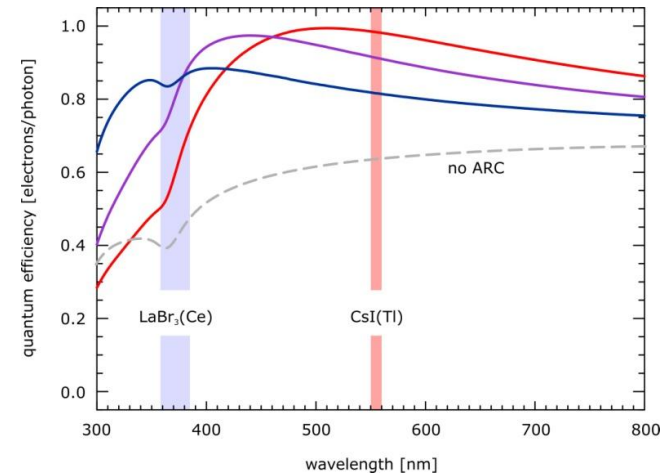
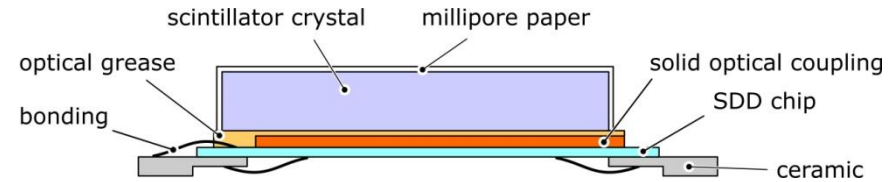
γ-ray spectroscopy

▷ SDD = scintillator readout device, "counting" of optical photons

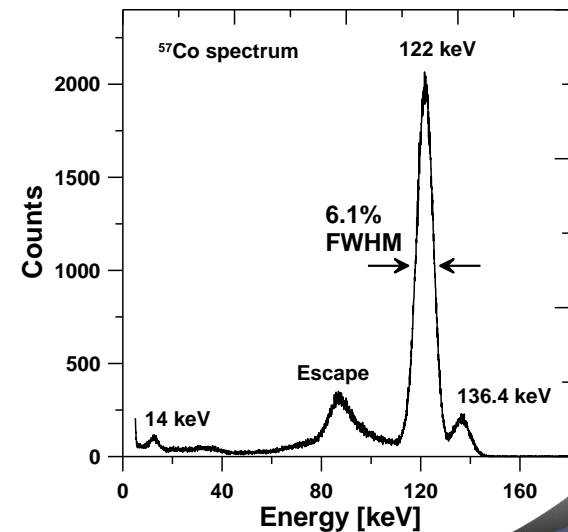
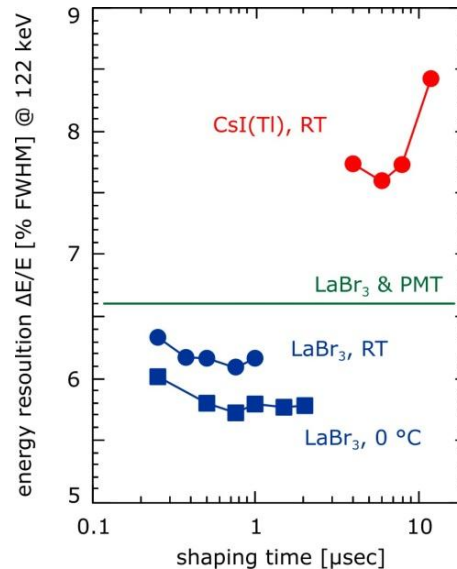
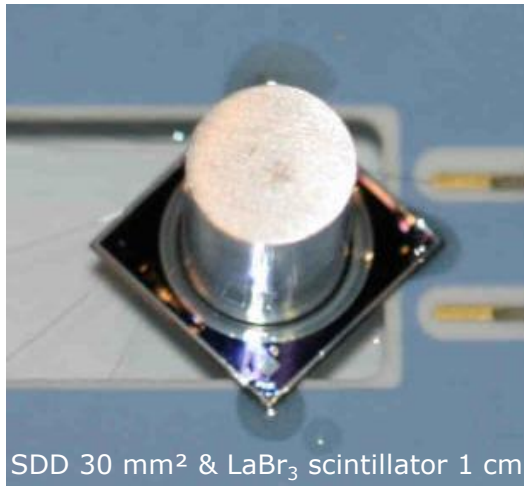
▷ scintillators	CsI(Tl)	LaBr ₃ (Ce)
- peak λ [nm]	550 – 565	360 - 380
- light output [ph/keV]	50	60
- decay time [nsec]	1.000	25

▷ anti-reflective coating (ARC): tuning of entrance window transmittance to scintillator wavelength

▷ example results: SDD 30 mm² (C. Fiorini, Politecnico di Milano)



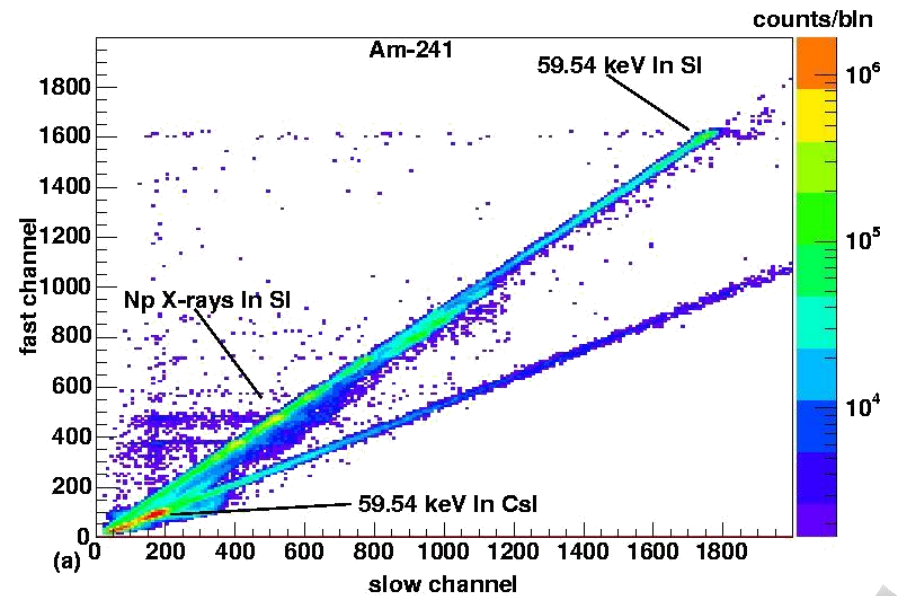
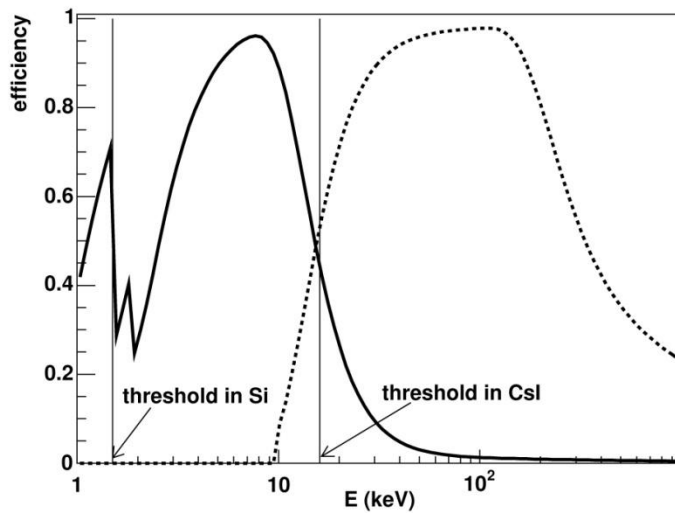
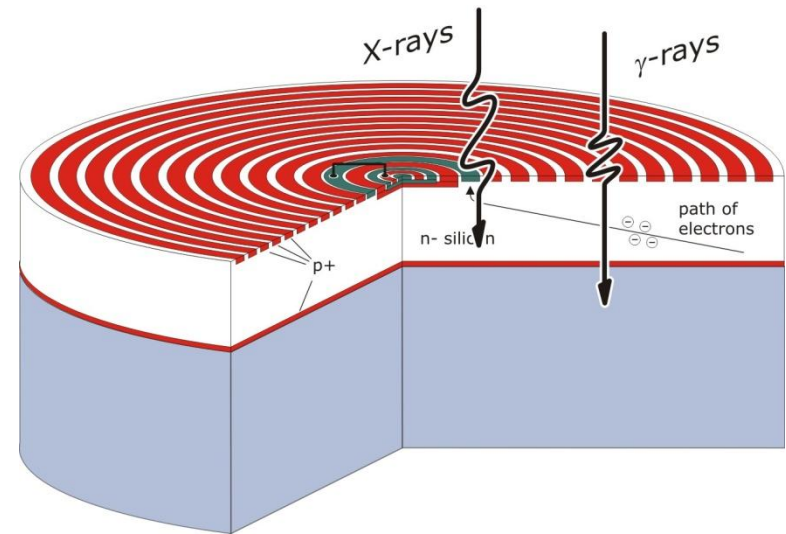
anti-reflective coating



combined X-ray & γ -ray spectroscopy

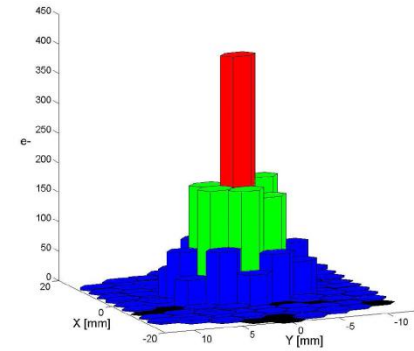
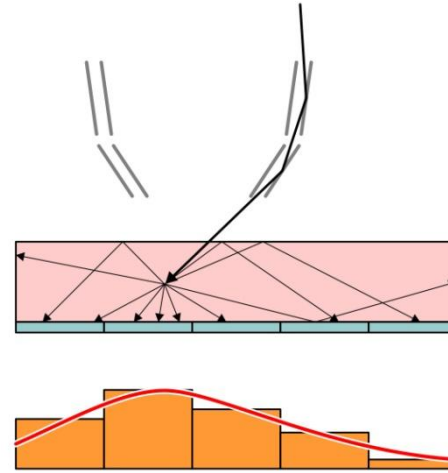
(C. Labanti, M. Marisaldi, CNR-IASF, Bologna)

- ▷ SDD 10 mm²
 - direct conversion of X-rays
 - low energy threshold: 1.5 keV
- ▷ CsI(Tl) scintillator
 - sensitive up to 1 MeV
- ▷ event classification by pulse shape discrimination

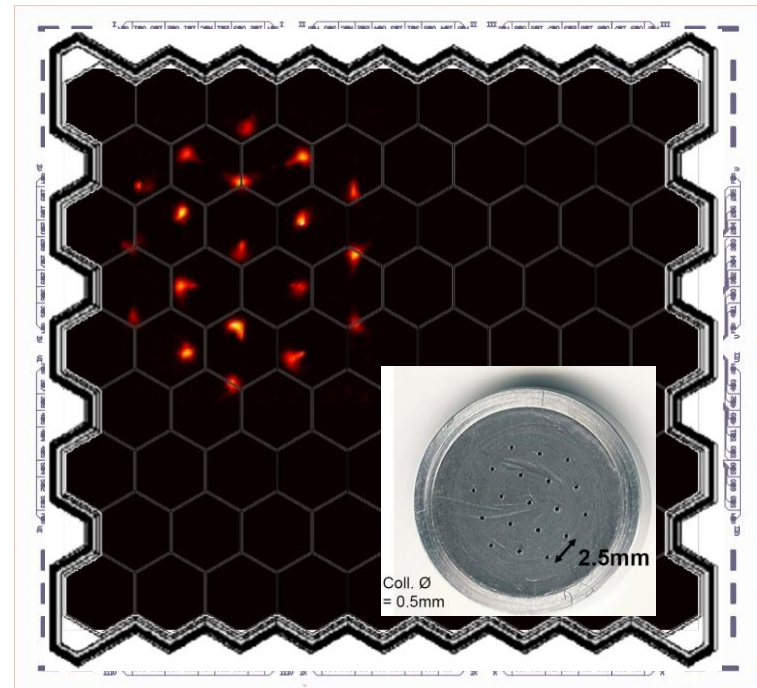


■ γ -camera

- ▷ monolithic scintillator & pixelated SDD
- ▷ position resolution by centroid of the light distribution
- ▷ (reduced) energy resolution
- ▷ e.g. DRAGO (C. Fiorini, Politecnico di Milano):
 - monolithic SDD array, 77 cells
 - cell size: $8.7 \text{ mm}^2 = \varnothing = 3.2 \text{ mm}$
 - area: $2.6 \times 2.9 \text{ cm}^2 = 6.7 \text{ cm}^2$
 - CsI scintillator, 5 mm
- ▷ spatial resolution
0.27 ... 0.55 mm FWHM
depending on the position relative to the cell center
NB: cell size 3.2 mm, 77 readout channels
- ▷ comparison
CdTe pixel detector
 - 300 / 500 μm pixels
 - 7.000 / 4.000 readout channels



light emission centroid

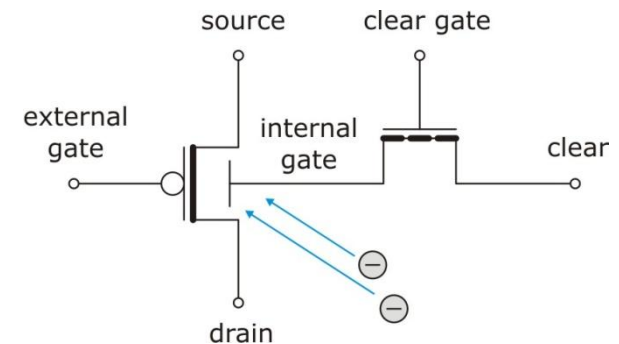
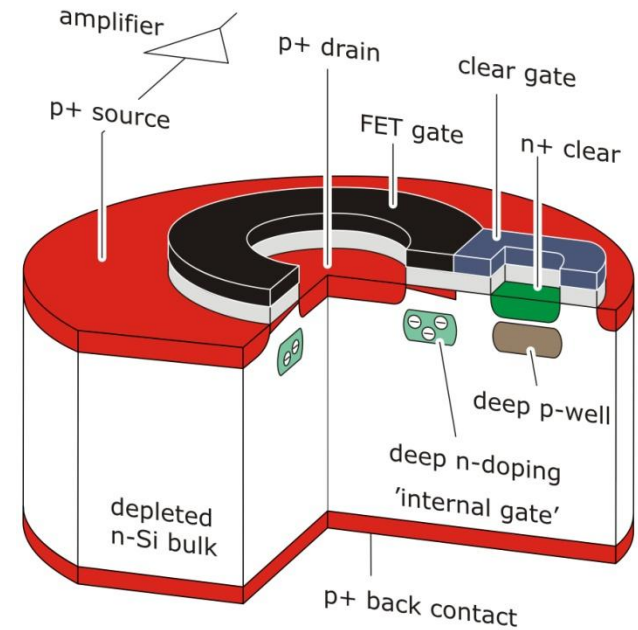


■ p-FET on depleted n-bulk

- ▷ signal charge collected in potential minimum below FET channel
- ▷ transistor current modulation 300 pA/el.

■ combined function of sensor & amplifier

- ▷ low capacitance (20 fF) and noise
 - ↳ excellent spectroscopic performance
- ▷ complete clearing of signal charge
 - ↳ no reset noise
- ▷ non-destructive readout
 - ↳ potential of repetitive readout
- ▷ charge storage capability
 - ↳ readout on demand
- ▷ backside illuminated, fully depleted
 - ↳ quantum efficiency



IXO Wide Field Imager

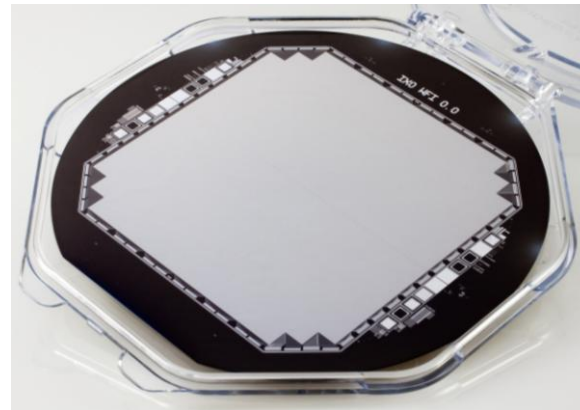
▷ format

- 6-inch wafer-scale device, $\sim 10 \times 10 \text{ cm}^2$
- $\sim 1024 \times 1024$ pixels ($100 \mu\text{m}$)

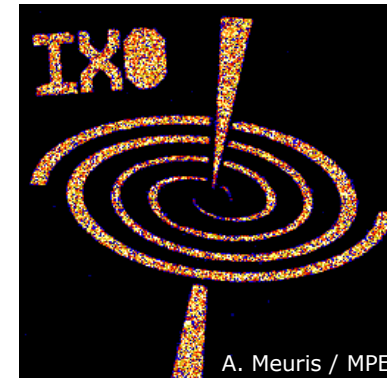
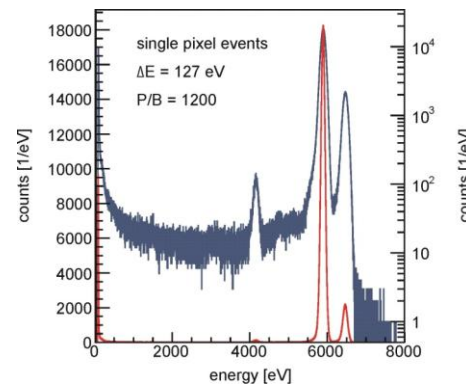
▷ framerate $\sim 0.5 \dots 1 \text{ kHz}$

▷ prototype (XEUS heritage)

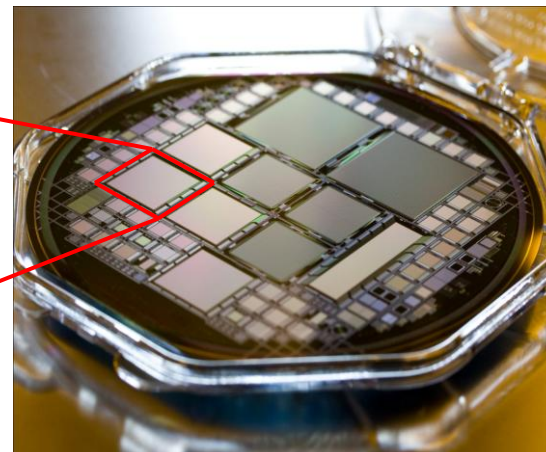
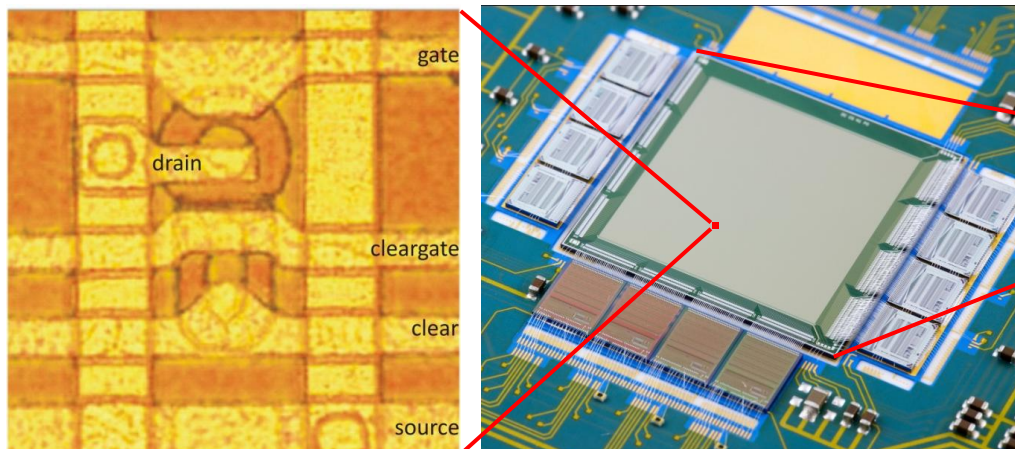
- 256×256 pixels ($75 \mu\text{m}$)
- $1.92 \times 1.92 \text{ cm}^2$
- readout 4 x ASTEROID ($6 \mu\text{sec} / \text{row}$)
- temperature $-5 \text{ }^\circ\text{C}$ (!)
- resolution 127 eV (singles)
 140 eV (all)
- σ (gain, noise, offset) $\sim \%$



IXO-WFI
mechanical
sample



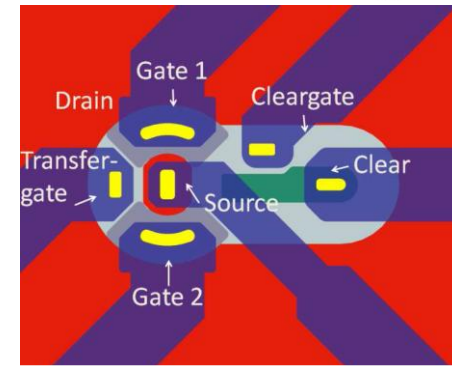
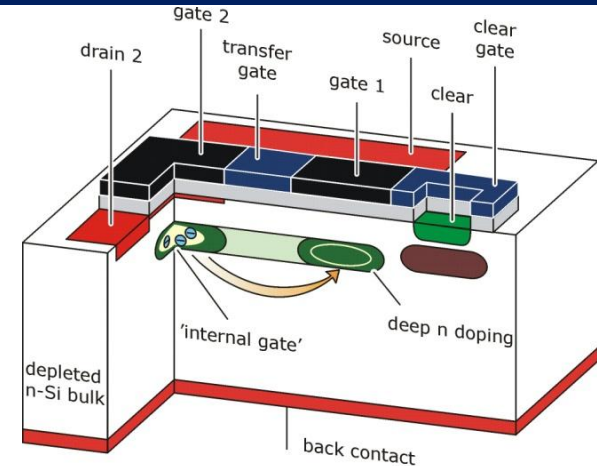
A. Meuris / MPE



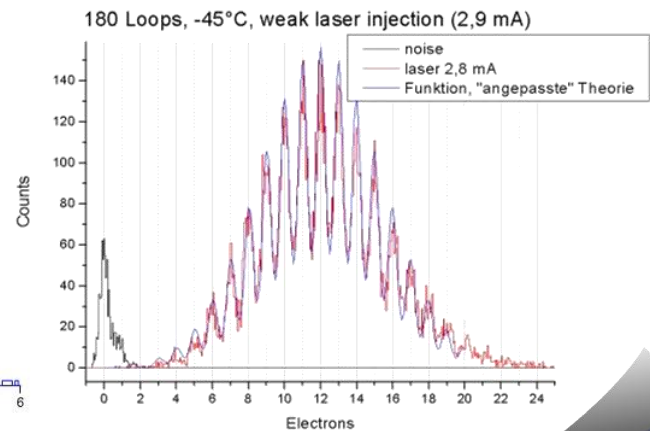
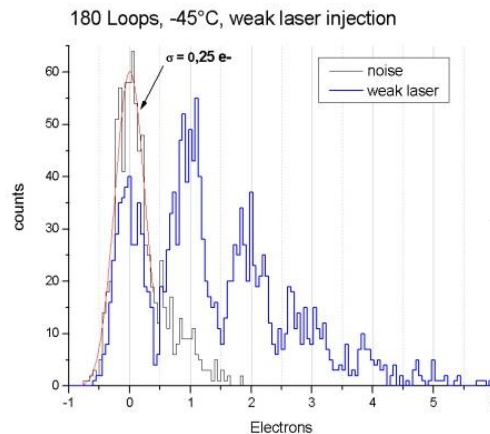
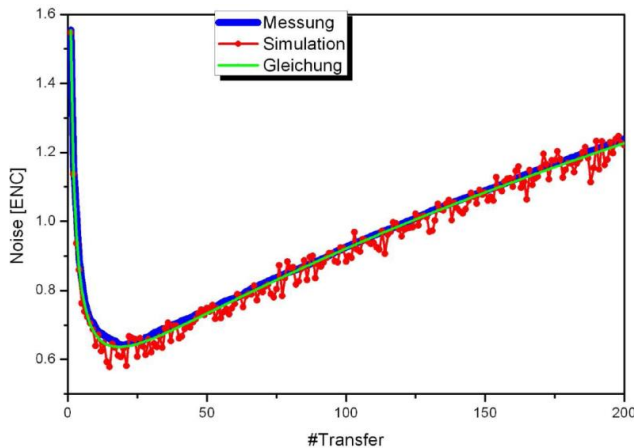
DePFET APS
 256×256
 $75 \mu\text{m}$ pixel

Repetitive Non-Destructive Readout ("PingPong")

- ▷ 2 DePFETs per pixel
 - 1 empty / 1 full
- ▷ intra-pixel charge transfer via transfer gate
- ▷ elimination of 1/f-noise by independent measurements
- ▷ noise $\sim 1/\sqrt{N}$, N = number of readings
- ▷ record resolution $\sigma = 0.25 \text{ el.}$
- ▷ 64 x 64 device in production
- ▷ applications
 - optical metrology
 - optical astronomy

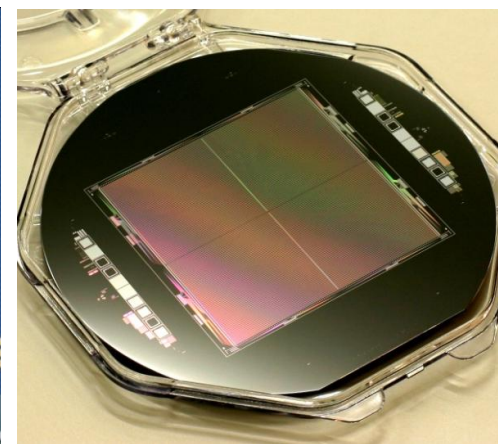
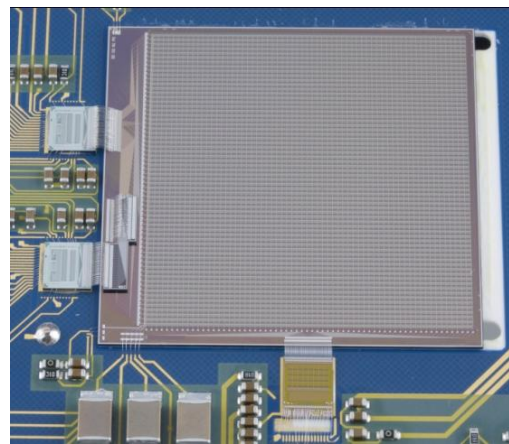
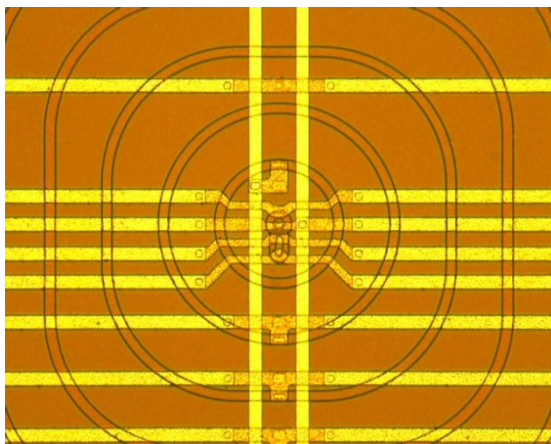
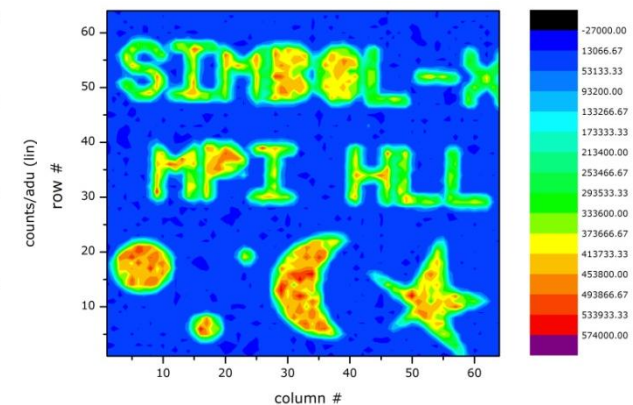
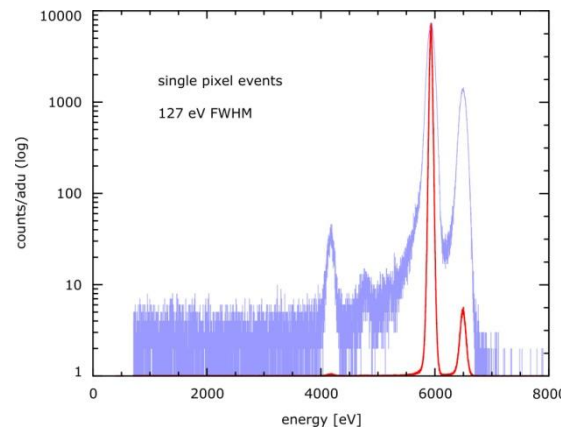
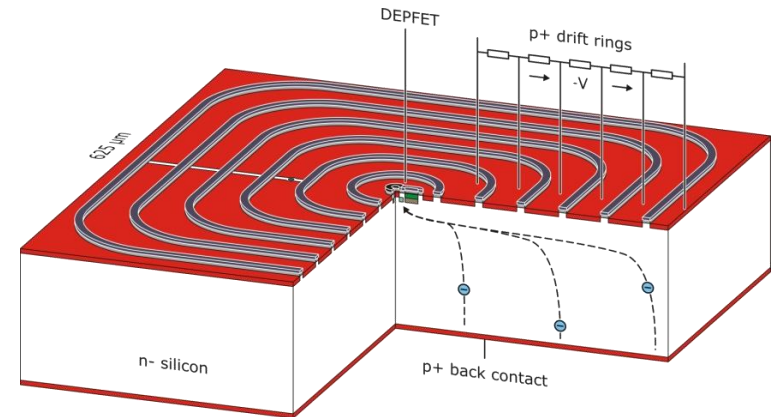


PingPong DePFET compact design



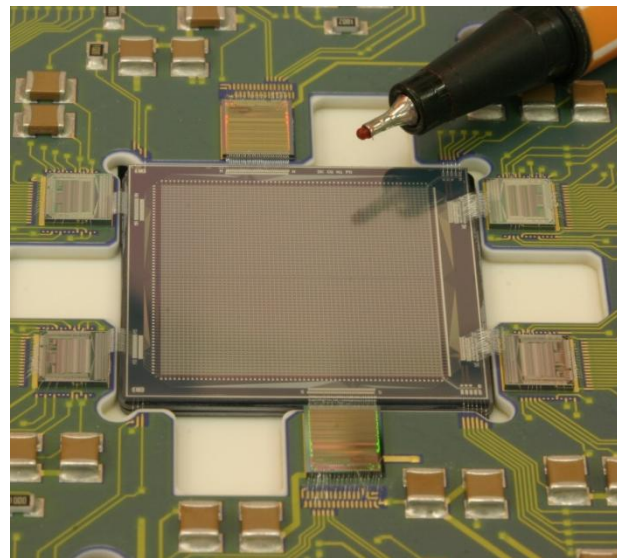
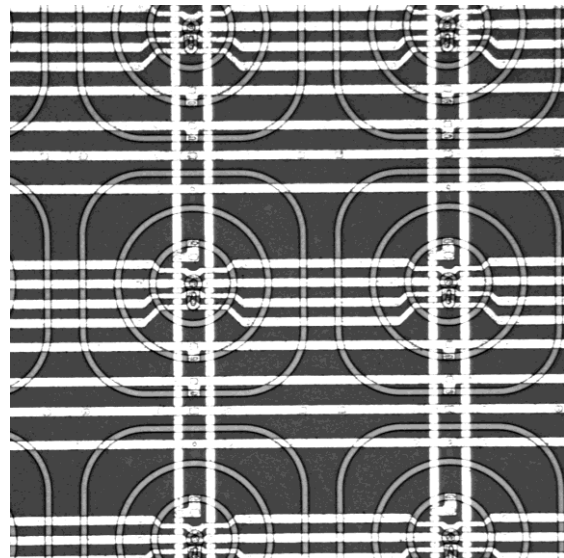
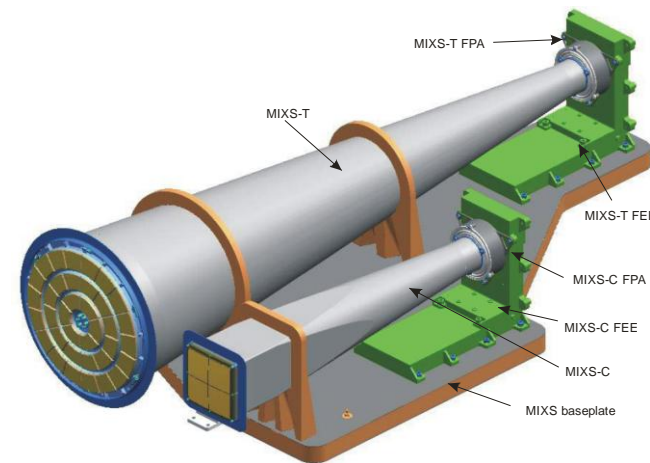
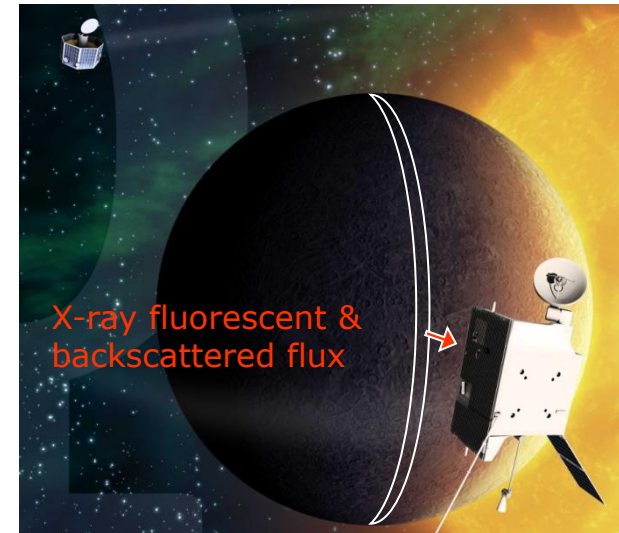
■ Simbol-X Low Energy Detector

- ▷ SDD + DePFET
macropixel sensor with scalable pixel size
- ▷ format
 - 128 x 128 pixels (625 μm)
- ▷ framerate 8 kHz
- ▷ quadrant prototype
 - 64 x 64 pixels (500 μm)



■ BepiColombo MIXS

- ▷ 2 imagers equipped with identical sensors:
 - MIXS-C collimator, wide field imaging (70 – 400 km)
 - MIXS-T mcp telescope, precise mapping (1 – 4 km)
- ▷ launch 2014, 5 y travel, 1 (+1) y lifetime
- ▷ challenges: radiation hardness, thermal & power budget
- ▷ macropixel sensor
 - 64 x 64 pixels (300 μm)
 - 1.92 x 1.92 cm^2
 - sensitivity: Fe-L (700 eV) ... Fe-K (6.4/7.1 keV)



- many advanced sensor types derived from one intelligent basic structure
- flexible device principles allowing for application specific designs